

Form PTO-1449

LIST OF PATENTS AND
PUBLICATIONS
FOR INFORMATION
DISCLOSURE STATEMENT
(Use Several Sheets if Necessary)

APPLICANT: Pawitter Mangat et al.

ATTY. DOCKET #: SC11661TP

APPL. #: Unknown

FILING DATE: Concurrently Herewith

GROUP: Unknown

JC872 U.S. PTO
09/927024

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SL	AA	US 6,261,726 B1	Jul.17,'01	Brooks et al.	430	5	Dec.6,'99
SL	AB	US 6,221,537 B1	Apr.24,'01	Thompson et al.	430	5	Dec.19,'97
SL	AC	6,159,558	Dec.12,'00	Wolfe et al.	427	523	Oct.12,'99
SL	AD	6,140,020	Oct.31,'00	Cummings	430	296	Nov.30,'98
SL	AE	6,124,063	Sep.26,'00	Dauksher et al.	430	5	Jul.30,'98
SL	AF	6,063,246	May 16,'00	Wolfe et al.	204	192.16	May 23,'97
SL	AG	6,051,346	Apr.18,'00	Kornblit et al.	430	5	Jul.23,'98
SL	AH	5,972,794	Oct.26,'99	Katakura	438	704	Mar.18,'98
SL	AI	5,942,760	Aug.24,'99	Thompson et al.	250	492.2	Nov.3,'97
SL	AJ	5,912,095	Jun.15,'99	Katakura	430	5	Jun.3,'97
SL	AK	5,899,728	May 4,'99	Mangat et al.	438	459	Dec.22,'97

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	PUBLICATION DATE (#43)	COUNTRY	CLASS	SUBCLASS
	AL					
	AM					
	AN					
	AO					
	AP					

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

SL	AR	Donald W. Pettibone et al., "UV Inspection of EUV and SCALPEL Reticles", 20 th Annual BACUS Symp. on Photomask Tech.; Proceedings of SPIE, Vol.4186 (2001);0277-786X/01, pgs.241-249.
SP	AS	Brian J. Grenon et al., "20 th Annual BACUS Symposium on Photomask Technology", 20 th Annual BACUS Symp. on Photomask Tech.; Proceedings of SPIE, Vol.4186 (2001);0277-786X, pgs. 717-723.
SL	AT	H.C.Pfeiffer et al., "Projection reduction exposure with variable axis immersion lenses: Next generation lithography", J. Vac. Sci. Technol. B 17(6), Nov/Dec 1999 American Vacuum Society, pgs. 1-7.
SL	AU	S. Kawata et al., "Stencil reticle development for electron beam projection system", J. Vac. Sci. Technol. B 17(6), Nov/Dec 1999 American Vacuum Society, pgs. 2864-2867.
SL	AV	I.W. Rangelow et al., "p-n junction-based wafer flow process for stencil mask fabrication", J. Vac. Sci. Technol. B 16(6), Nov/Dec 1998 American Vacuum Society, pgs. 3592-3598.
SL	AW	P. Hudek et al., "Directly sputtered stress-compensated carbon protective layer for silicon stencil masks", J. Vac. Sci. Technol. B 17(6), Nov/Dec 1999 American Vacuum Society, pgs. 3127-3131.

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DATE CONSIDERED

10/20/03

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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EXAMINER INITIAL		DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SDm	BA	5,674,413	Oct. 7, '97	Pfeiffer et al.	219	121.25	Nov. 22, '95
SDm	BB	5,464,711	Nov. 7, '95	Mogab et al.	430	5	Aug. 1, '94
	BC						
	BD						
	BE						
	BF						
	BG						
	BH						
	BI						
	BJ						
	BK						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	PUBLICATION DATE (#43)	COUNTRY	CLASS	SUBCLASS
	BL					
	BM					
	BN					
	BO					
	BP					

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	BR	
	BS	
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	BV	
	BW	
	BX	
	BY	
	BZ	

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete if Known			
		Application Number	09/927,024		
		Filing Date	August 9, 2001		
		First Named Inventor	Pawitter Mangat		
		Group Art Unit	1756		
		Examiner Name	Unassigned		
Sheet		of		Attorney Docket Number	SC11661TP

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U. S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. 1	U.S. Patent Document ²		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
SKM	CA	2002/0001964	A1	Choi	01/30/2002	
SKM	CB	6,316,151	B1	Kim <i>et al.</i>	11/13/2001	
SKM	CC	6,004,700		Greschner <i>et al.</i>	12/21/1999	
SKM	CD	5,935,739		Bayer <i>et al.</i>	08/10/1999	
SKM	CE	5,523,185		Goto	06/04/1996	
SKM	CF	5,500,312		Harriott <i>et al.</i>	03/19/1996	

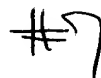
FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. 1	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T 6
		Office ³	Number 4	Kind Code ² (if known)				
SKM	CG	JP	10010706		Kenichi	01/16/1998		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
SKM	CH	PCT/US02/24164 Search Report mailed February 5, 2003.	

Examiner Signature	mohamedulla	Date Considered	10/20/03
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¹ Unique citation designation number. ² See Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English Language Translation is attached.



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Complete if Known

Application Number	09/927,024
Filing Date	08-09-2001
First Named Inventor	Pawitter Mangat
Group Art Unit	1756
Examiner Name	Saleha R. Mohamedulla
Attorney Docket Number	SC11661TP

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10/20/03

¹ Unique citation designation number. ² See Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English Language Translation is attached.